Search Notes

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Application/Control No.	Applicant(s)/Patent under Reexamination
09/854,463	HANNUKSELA ET AL.
Examiner	Art Unit
Erick Rekstad	2621

SEARCHED			
Class	Subclass	Date	Examiner
375	240.27 240.01 240.13 240.25		ER
386	117		ER
382	232		ER
348	14.01		ER
348	14.02		ER

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
375	240.25	5/27/2005	ER	
375	240.27	11/14/2005	ER	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
IEEE: error <and> concealment <and> video</and></and>	5/27/2005	ER	
IEEE, ACM Digital Library, CiteSeer, Optics Information Database search for (h.263 and supplemental enhancement)	11/14/2005	ER	
keyword search	7/21/2004	ER	
keyword search	5/27/2005	ER	
keyword search	11/14/2005	ER	
keyword search	9/1/2006	ER	
keyword search	12/10/2006	ER	
PLUS search	4/20/2007	ER	